

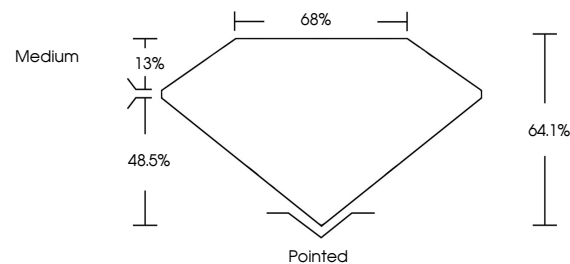


ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

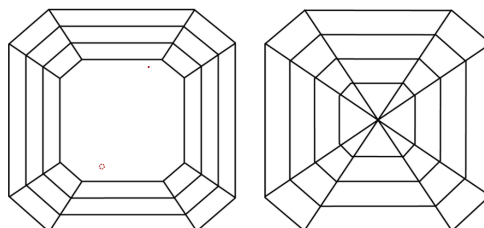
LG743513292
Report verification at igi.org

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| FL | IF | VVS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |

LABORATORY GROWN DIAMOND REPORT



October 15, 2025

IGI Report Number **LG743513292**Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **SQUARE EMERALD CUT**

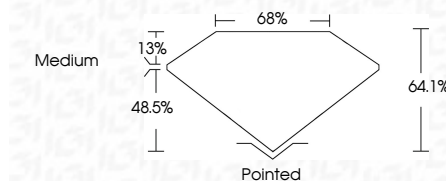
Measurements **6.57 X 6.49 X 4.16 MM**

GRADING RESULTS

Carat Weight **1.59 CARAT**

| | |
|-------------|---|
| Color Grade | E |
|-------------|---|

Clarity Grade VS 1



ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**Symmetry **EXCELLENT**Fluorescence **NONE**Inscription(s) LG743513292

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa



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October 15, 2025
GI Report No LG743513292
SQUARE EMERALD CUT

| | |
|-----------------------|------------------------|
| 5.57 X 6.49 X 4.16 MM | 1.59 CARAT |
| Color Grade | E |
| Clarity Grade | VS 1 |
| Depth | 64.1% |
| Table | 66% |
| Girdle | Medium |
| Quiet | Pointed |
| Polish | EXCELLENT |
| Symmetry | EXCELLENT |
| Fluorescence | NONE |
| Production Date | Jan 1 1978 (est.) 1990 |

Comments:
This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.